

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of
Shunpei YAMAZAKI et al.

Serial No. 10/084,935

Filed: March 1, 2002

For: INSULATING FILM AND)
METHOD OF PRODUCING)
SEMICONDUCTOR DEVICE)



Art Unit: 2815

Examiner: B. Baumeister

CERTIFICATE OF MAILING

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P.O. Box 1450, Alexandria, VA 22313-1450, on June 23, 2003.

Adele M. Stamper
Adele M. Stamper

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the non-final Official Action mailed January 22, 2003, the period
for responding having been extended two (2) months, please consider the following
amendments and remarks in connection with the above-identified application.

IN THE CLAIMS:

Please amend claim 26 as follows. Claim 26 is presented below in its amended
form. The amendment to the above-noted claim is outlined in an Attachment to the
Amendment using the conventional indication method of bracketing and underlining.

26. (Amended) A device according to claim 25,
wherein the organic silane comprises at least a material selected from the group
consisting of $\text{Si}(\text{OC}_2\text{H}_5)_4$, $\text{Si}_2\text{O}(\text{OC}_2\text{H}_5)_6$, $\text{Si}_3\text{O}_2(\text{OC}_2\text{H}_5)_8$, $\text{Si}_4\text{O}_3(\text{OC}_2\text{H}_5)_{10}$, and
 $\text{Si}_5\text{O}_4(\text{OC}_2\text{H}_5)_{12}$.

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